



AF/2615
#81B N.E
6-14-04
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MAIL STOP AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2615

03500.014856

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIDEO HONMA) Examiner: Y. Aggarwal
Application No.: 09/678,253) Group Art Unit: 2615
Filed: October 3, 2000)
For: OUTPUT CONTROL METHOD AND)
APPARATUS, AND STORAGE MEDIUM : June 7, 2004

RECEIVED

JUN 09 2004

Technology Center 2600

MAIL STOP AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Official Action dated April 7, 2004, Applicant respectfully requests that the following amendments and remarks be entered and considered in the above-identified application.